



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

**Jarma Ilmari Maula, Hannu Leskinen,
Teemu Lang, Pekka Kuosmanen, Kari
Härkönen, and Bradley J. Aitchison**

Application No. 10/609,136

Filed: June 26, 2003

For: **DIAPHRAGM VALVE FOR HIGH-
TEMPERATURE PRECURSOR
SUPPLY IN ATOMIC LAYER
DEPOSITION**

Date: November 14, 2003

Confirmation No. 6735

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TRANSMITTAL LETTER

TO THE COMMISSIONER FOR PATENTS:

Enclosed for filing in the above-referenced application are the following:

- ☒ Fee Transmittal
- ☒ Form PTO-1533 - Notice to File Missing Parts of Application, Filing Date Granted
- ☒ Declaration for Patent Application (in 2 counterparts)
- ☒ Power of Attorney by Assignee of Entire Interest (Revocation of Prior Powers)
- ☒ Information Disclosure Statement
- ☒ Form PTO/SB/08 (3 pgs.) and copies of cited references
- ☒ A check for \$1440.00 in payment of:
 - Filing Fee - \$770.00
 - Additional Claims Filing Fee - \$540.00
 - Surcharge for Late Filing Fee or Oath - \$130.00
- ☒ Return receipt postcard

The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455.

Respectfully submitted,

Planar Systems, Inc.

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